

ITW

PATENT APPLICATION

CERTIFICATE OF MAILING/FACSIMILE TRANSMISSION (37 CFR 1.8)



I hereby certify that this paper (along with any paper referred to as being transmitted therewith) is (XXX) being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box. 1450, Alexandria, Virginia 22313-1450 or () being transmitted by facsimile to the U.S. Patent and Trademark Office. (Fax No. 571 273-8300) (pages). This facsimile is being sent from (908) 429-3650.

Maria T. Sanchez
(Print Name)

Date: February 16, 2006

Maria T. Sanchez
(Signature)

Docket No. 2003JP314

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Tatsuro NAGAHARA et al.

Art Unit: To Be Assigned

Serial No. 10/564,997, filed January 13, 2006

Examiner: To be Assigned

For: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND
METHOD FOR FORMING PATTERNED RESIST FILM**

**INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF FILING
OR BEFORE MAILING OF THE FIRST OFFICE ACTION
(37 CFR 1.97 (b))**

February 16, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Serial No.: 10/564,997
Filed: January 13, 2006

Dear Sir:

1. IDENTIFICATION OF TIME OF FILING INFORMATION DISCLOSURE STATEMENT

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 CFR 1.97(b).

2. PRELIMINARY STATEMENTS

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

Pursuant to the notice in the Official Gazette notice of 5 August 2003, 1276 O.G. 55, copies of US Patents and/or US Patent Publications are not being enclosed as the present application has a filing date after June 30, 2003.

3. COMPLETED FORM PTO-1449 IS ATTACHED.

4. IDENTIFICATION OF PRIOR APPLICATION IN WHICH LISTED INFORMATION WAS ALREADY CITED AND FOR WHICH NO COPIES ARE SUBMITTED OR NEED BE SUBMITTED

[] This application relies, under 35 U.S.C. 120, on the earlier filing date of prior application Serial No. _____ filed on _____.

5. COPIES OF LISTED INFORMATION ITEMS ACCOMPANYING THIS STATEMENT

US 5,468,494
US 5,900,352
US 5,994,031
US 2002/0055066
US 2003/0113657
US 2004/0081912

JP 5-88373
JP 2000-181069
JP 2001-288270
JP 2002-311591
JP 2002-72502
JP 2002-72504

Serial No.: 10/564,997
Filed: January 13, 2006

English Language Abstract of JP 5-088373
English Language Abstract of JP 7-234522
English Language Abstract of JP 11-295899
English Language Abstract of JP 2000-1818069
English Language Abstract of JP 2001-288270
English Language Abstract of JP 2002-229219
English Language Abstract of JP 2002-311591
English Language Abstract of JP 2002-351091
English Language Abstract of JP 2002-72502
English Language Abstract of JP 2002-72504
English Language Abstract of JP 2003-114537
English Language Abstract of JP 2003-131396
English Language Abstract of JP 2003-167329
English Language Abstract of JP 2003-195518
English Language Abstract of JP 2003-295469
English Language Abstract of JP 2003-5382
English Language Abstract of JP 2004-109442
English Language Abstract of JP 2004-126266
English Language Abstract of JP 2004-86180

Machine Language English Translation from JPO of JP 5-88373
Machine Language English Translation from JPO of JP 2000-181069
Machine Language English Translation from JPO of JP 2001-288270
Machine Language English Translation from JPO of JP 2002-311591
Machine Language English Translation from JPO of JP 2002-72502
Machine Language English Translation from JPO of 2002-72504
Machine Language English Translation from JPO of JP 2003-295469
Machine Language English Translation from JPO of JP 2004-109442
Machine Language English Translation from JPO of JP 2004-126266
Machine Language English Translation from JPO of JP 2004-86180

Legible copies of all items listed accompany this information statement except as noted herein.

Pursuant to the Official Gazette notice of 5 August 2003, 1276 O.G. 55, since this application entered the National Stage under 35 USC 371 after June 30, 2003, applicant is not enclosing copies of the above mentioned U.S. patents and/or U.S. patent publications.

[] Items in prior application from which an earlier filing date is claimed for this application as identified in No. 4 above.

6. TRANSLATION(S) OF NON-ENGLISH LANGUAGE DOCUMENTS

[X] Submitted herewith is an English language abstract of the following foreign language patents, publications or information or of those portions of those patents, publications or information considered to be material:

English Language Abstract of JP 5-088373
English Language Abstract of JP 7-234522
English Language Abstract of JP 11-295899
English Language Abstract of JP 2000-1818069
English Language Abstract of JP 2001-288270
English Language Abstract of JP 2002-229219
English Language Abstract of JP 2002-311591
English Language Abstract of JP 2002-351091
English Language Abstract of JP 2002-72502
English Language Abstract of JP 2002-72504
English Language Abstract of JP 2003-5382
English Language Abstract of JP 2003-114537
English Language Abstract of JP 2003-131396
English Language Abstract of JP 2003-167329
English Language Abstract of JP 2003-195518
English Language Abstract of JP 2003-295469
English Language Abstract of JP 2004-109442
English Language Abstract of JP 2004-126266
English Language Abstract of JP 2004-86180

Machine Language English Translation from JPO of JP 5-88373
Machine Language English Translation from JPO of JP 2000-181069
Machine Language English Translation from JPO of JP 2001-288270
Machine Language English Translation from JPO of JP 2002-311591
Machine Language English Translation from JPO of JP 2002-72502
Machine Language English Translation from JPO of 2002-72504
Machine Language English Translation from JPO of JP 2003-295469
Machine Language English Translation from JPO of JP 2004-109442
Machine Language English Translation from JPO of JP 2004-126266
Machine Language English Translation from JPO of JP 2004-86180

[X] No English language translations of the foreign language patents, publications or information or parts thereof are readily available, except those listed above.

[X] The following foreign language documents submitted are believed to be the equivalent or substantial equivalent of the English language documents identified below, which are also submitted herewith:

Serial No.: 10/564,997
Filed: January 13, 2006

US 2003/0113657 is equivalent to JP 2002-72502 and JP 2002-72504
US 2004/0081912 is equivalent to JP 2000-181069

Pursuant to the Official Gazette notice of 5 August 2003, 1276 O.G. 55, since this application entered the National Stage under 35 USC 371 after June 30, 2003, applicant is not enclosing copies of the above mentioned U.S. patents and/or U.S. patent publications.

Copies of JP 7-234522, JP 11-295899, JP 2002-229219, JP 2002-351091, JP 2003-114537, JP 2003-131396, JP 2003-167329, JP 2003-195518, JP 2003-295469, JP 2003-5382, JP 2004-109442, JP 2004-126266, and JP 2004-86180 are not enclosed as they were cited in the International Search Report submitted with applicants' National Stage filing.

8. IDENTIFICATION OF PERSON(S) MAKING THIS INFORMATION
DISCLOSURE STATEMENT

The person making this statement is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted:



Attorney for Applicant(s)
Sangya Jain
(Reg. No. 38, 504)
AZ Electronic Materials USA Corp.
70 Meister Avenue
Somerville, New Jersey 08876
Telephone: (908) 429-3536
Telefax: (908) 429-3650

Customer No. 26,289

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

FEB 21 2006

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this **Information Disclosure Citation - 4 Pages**

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) 2003JP314		Application Number 10/564,997	
		Applicant(s) Tatsuro NAGAHARA et al.			
		Filing Date January 13, 2006		Group Art Unit To Be Assigned	

*EXAMINER INITIAL		OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>
		English Language Abstract of JP 11-295899.
		English Language Abstract of JP 2000-181069.
		English Language Abstract of JP 2001-288270.
		English Language Abstract of JP 2002-229219.
		English Language Abstract of JP 2002-351091.
		English Language Abstract of JP 2002-72502.
		English Language Abstract of JP 2002-72504.
		English Language Abstract of JP 2003-114537.
		English Language Abstract of JP 2003-131396.
		English Language Abstract of JP 2003-167329.
		English Language Abstract of JP 2003-195518.
		English Language Abstract of JP 2003-295469.
EXAMINER		DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) <div style="text-align: center;">2003JP314</div>		Application Number <div style="text-align: center;">10/564,997</div>	
		Applicant(s) <div style="text-align: center;">Tatsuro NAGAHARA et al.</div>			
		Filing Date <div style="text-align: center;">January 13, 2006</div>		Group Art Unit <div style="text-align: center;">To Be Assigned</div>	
*EXAMINER INITIAL	OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>				
EXAMINER		DATE CONSIDERED			
<p>*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>					

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al**

Docket No.

2003JP314

Serial No.

10/564-097

Filing Date

January 13, 2006

Examiner


To Be Assigned

Group Art Unit

To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this **JP 5-88373 - 4 Pages***(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006*(Date)***MARIA T. SANCHEZ***(Typed or Printed Name of Person Mailing Correspondence)*
*(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**


I hereby certify that this **Machine English Language Translation from JPO of JP 5-88373 - 5 Pages**
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006**
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

FEB 21 2006 January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM

I hereby certify that this JP 2000-181069 - 15 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)		Docket No.	
Applicant(s): Tatsuro NAGAHARA et al.		2003JP314	
Serial No. 10/564,997	Filing Date FEB 21 2006 January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
Invention: DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM			
<p>I hereby certify that this <u>Machine English Language Translation from JPO of JP 2000-181069 - 17 Pages</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on <u>February 16, 2006</u> (Date)</p> <p><u>MARIA T. SANCHEZ</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p><u>Maria T. Sanchez</u> (Signature of Person Mailing Correspondence)</p>			
<p>Note: Each paper must have its own certificate of mailing.</p>			

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.

10/564,997

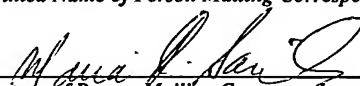
Filing Date
February 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILMI hereby certify that this JP 2001-288270 - 13 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The
Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.
10/564,997Filing Date
FEB 21 2006
January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this Machine English Language Translation from JPO of JP 2001-288270 - 17 Pages
(Identify type of correspondence)is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The
Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez
(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this JP 2002-72502 - 10 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006


(Date)

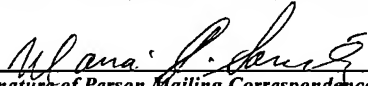
MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)		Docket No.	
Applicant(s): Tatsuro NAGAHARA et al.		2003JP314	
Serial No. 10/564,997	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
Invention: DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM			
<p>I hereby certify that this <u>Machine English Language Translation from JPO of JP 2002-72502 - 13 Pages</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on <u>February 16, 2006</u> (Date)</p> <p><u>MARIA T. SANCHEZ</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p><u></u> (Signature of Person Mailing Correspondence)</p> <p>Note: Each paper must have its own certificate of mailing.</p>			

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)			Docket No. 2003JP314	
Applicant(s): Tatsuro NAGAHARA et al.				
Serial No. 10/564,997	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned	
Invention: DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM				
<p>I hereby certify that this <u>JP 2002-72504 - 11 Pages</u> <i>(Identify type of correspondence)</i></p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on <u>February 16, 2006</u> <i>(Date)</i></p> <p><u>MARIA T. SANCHEZ</u> <i>(Typed or Printed Name of Person Mailing Correspondence)</i></p> <p><u></u> <i>(Signature of Person Mailing Correspondence)</i></p> <p>Note: Each paper must have its own certificate of mailing.</p>				

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al**

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this **Machine English Language Translation from JPO of JP 2002-72504 - 13 Pages**
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

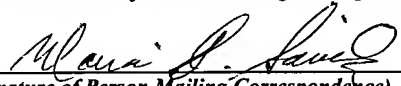
Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006**
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)			Docket No.	
Applicant(s): Tatsuro NAGAHARA et al			2003JP314	
Serial No. 10/564,997	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned	
Invention: DEVELOPMENT OF A METHOD FOR PHOTOREDUCTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM				
<p>I hereby certify that this <u>JP 2002-311591 - 21 Pages</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on <u>February 16, 2006</u> (Date)</p> <p><u>MARIA T. SANCHEZ</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p><u></u> (Signature of Person Mailing Correspondence)</p>				
<p>Note: Each paper must have its own certificate of mailing.</p>				

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

FEB 21 2006
January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this Machine English Language Translation from JPO of JP 2002-311591 - 34 Pages
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

FEB 21 2006 January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this English Language Abstract of JP 5-88373 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)			Docket No.	
Applicant(s): Tatsuro NAGAHARA et al			2003JP314	
Serial No. 10/564,997	Stamp: OFFICE OF THE COMMISSIONER OF PATENTS AND TRADEMARKS FEB 21 2006	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned
Invention: DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM				
<p>I hereby certify that this <u>English Language Abstract of JP 7-234522 - 2 Pages</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on <u>February 16, 2006</u> (Date)</p> <p><u>MARIA T. SANCHEZ</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p><u>Maria T. Sanchez</u> (Signature of Person Mailing Correspondence)</p>				
<p>Note: Each paper must have its own certificate of mailing.</p>				

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

FEB 21 2006 January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this English Language Abstract of JP 2002-311591 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez
(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)			Docket No.	
Applicant(s): Tatsuro NAKAHARA et al.			2003JP314	
Serial No. 10/564,997	Filing Date January 13, 2006	Examiner To Be Assigned	Group Art Unit To Be Assigned	
Invention: DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM				
<p>I hereby certify that this <u>English Language Abstract of JP 11-295899 - 2 Pages</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on <u>February 16, 2006</u> (Date)</p> <p><u>MARIA T. SANCHEZ</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p><u>Maria T. Sanchez</u> (Signature of Person Mailing Correspondence)</p>				
<p>Note: Each paper must have its own certificate of mailing.</p>				

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention

DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILMI hereby certify that this English Language Abstract of JP 2000-288069 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

January 13, 2006

To Be Assigned

To Be Assigned

Invention

DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILMI hereby certify that this English Language Abstract of JP 2001-288270 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

FEB 21 2006 10/564,997

January 13, 2006

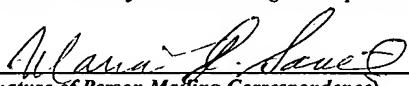
To Be Assigned

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this English Language Abstract of JP 2002-229219 - 1 Page*(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006*(Date)*MARIA T. SANCHEZ*(Typed or Printed Name of Person Mailing Correspondence)*
*(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Docket No.

2003JP314

Applicant(s): Tatsuro NAGAHARA et al.

FEB 21 2006

Serial No.

10/564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Inventor(s): **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this English Language Abstract of JP 2002-351091 - 1 Page

(Identify type of correspondence)

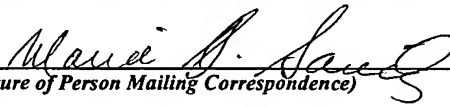
is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

0564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention:

DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILMI hereby certify that this English Language Abstract of JP 2002-72502 - 1 Page

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

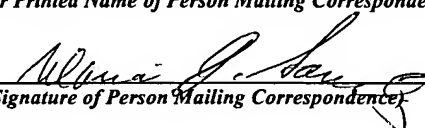
Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

FEB 21 2006 10:54,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this **English Language Abstract of JP 2002-72504 - 2 Pages***(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006***(Date)***MARIA T. SANCHEZ***(Typed or Printed Name of Person Mailing Correspondence)*
*(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

10/264,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention:

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this **English Language Abstract of JP 2003-114537 - 1 Page***(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006*(Date)***MARIA T. SANCHEZ***(Typed or Printed Name of Person Mailing Correspondence)*
*(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

10/554,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Inventor(s)

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this English Language Abstract of JP 2003-131396 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Docket No.

2003JP314

Applicant(s): Tatsuro NAGAHARA et al.

Serial No.

Filing Date

Examiner

Group Art Unit

FEB 21 2006
10/564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention Title

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this English Language Abstract of JP 2003-167329 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)**Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this **English Language Abstract of JP 2003-195518 - 2 Pages***(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006***(Date)***MARIA T. SANCHEZ***(Typed or Printed Name of Person Mailing Correspondence)**(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

2003JP314

Serial No.

10564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this **English Language Abstract of JP 2003-295469 - 1 Page***(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006***(Date)***MARIA T. SANCHEZ***(Typed or Printed Name of Person Mailing Correspondence)**(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

10254,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**

I hereby certify that this English Language Abstract of JP 2003-5392 - 1 Page

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

10/84,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**

I hereby certify that this English Language Abstract of JP 2004-126266 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)


(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

FEB 21 2006 10/564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this English Language Abstract of JP 2004-86180 - 1 Page*(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on

February 16, 2006*(Date)*MARIA T. SANCHEZ*(Typed or Printed Name of Person Mailing Correspondence)*
*(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Docket No.

2003JP314

Applicant(s): Tatsuro NAGAHARA et al.

Serial No.

Filing Date

Examiner

Group Art Unit

10/564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this English Language Abstract of JP 2004-109442 - 2 Pages

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006

(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

10/564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

I hereby certify that this Machine English Language Translation from JPO of JP 2003-295469 - 25 Pages
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez
(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

2003JP314

Serial No.

10564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention

**DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**

I hereby certify that this **Machine English Language Translation from JPO of JP 2004-109442 - 32 Pages**
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006**
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

Serial No.

Filing Date

Examiner

Group Art Unit

FEB 21 2006
10/564,997

January 13, 2006

To Be Assigned

To Be Assigned

Invention

DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM

I hereby certify that this Machine English Language Translation from JPO of JP 2004-126266 - 28 Pages
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The
Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Docket No.

2003JP314

Applicant(s): Tatsuro NAGAHARA et al.

Serial No.

10564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Inventor: **DEVELOPING SOLUTION FOR PHOTSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**

I hereby certify that this Machine English Language Translation from JPO of JP 2004-86180 - 41 Pages
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The

Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)

MARIA T. SANCHEZ

(Typed or Printed Name of Person Mailing Correspondence)

Maria T. Sanchez
(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.